10-02-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: UCF-306RCE Application Serial No.: 10/082,658

Filed: 10/19/2001

First Named Inventor: Martin Richardson

Examiner: Thomas, Courtney D.

Group: 2882

For: EUV, XUV, AND X-RAY WAVELENGTH SOURCES CREATED FROM LASER PLASMA PRODUCED FROM LIQUID METAL SOLUTIONS, AND NANO-SIZE PARTICLES IN SOLUTIONS

Commissioner of Patents and Trademarks Patent and Trademark Office Mail Stop RCE P O Box 1450

Alexandria, VA 22313-1450

Honorable Commissioner:

I enclose the following:

- REQUEST FOR CONTINUED EXAMINATION and attachments; 1.
- Petition Requesting Consideration of Information Disclosure Statement; 2.
- Supplemental Form PTO-1449; 3.
- Check in the amount of \$565.00. (\$180.00 is attached under 37 CFR 1.17(p)) (\$385.00 RCE filing fee)

Applicant respectfully request that you enter the attached of record in the above referenced utility patent application.

Respectfully submitted,

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I certify that this correspondence, including the attachments listed, is being deposited with the United States Postal Service, Express Mail Post Office to Addressee service, receipt No. EV326224600US, in an envelope addressed to Assistant

Commissioner for Patents, Mail Stop RCE,, P O Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Date of Mailing Signature of Person Mailing